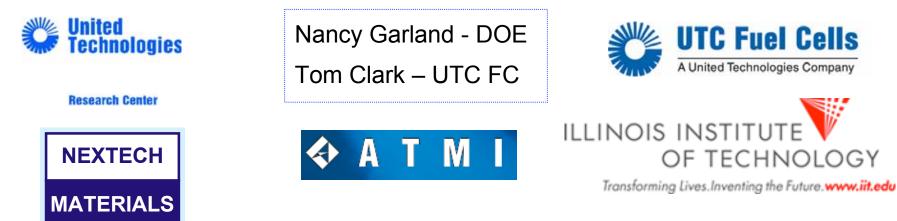
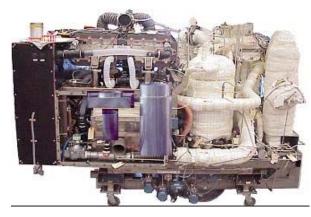
Development of Sensors for Automotive PEM-based Fuel Cells

DOE Agreement DE-FC04-02AL67616



DOE Hydrogen and Fuel Cells 2004 Annual Merit Review



UTC FC Series 200 - 50 kW PEM

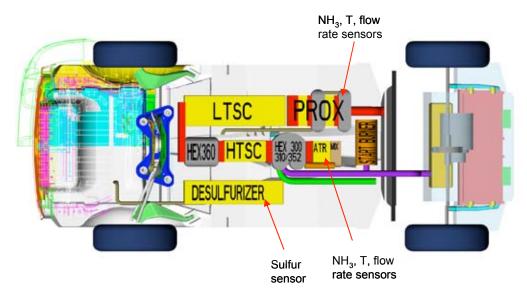
May 26, 2004



This presentation does not contain any proprietary or confidential information

Sensors for Automotive PEM Fuel Cells – Objectives

Develop a technology and commercial supplier base for physical and chemical sensors required to optimize the operation of PEM fuel cell power plants for automotive applications with path to low cost (<\$20 / sensor) at 500k qty.



•Chemical sensors

–Process streams: before, in, and after reformer, before and in fuel cell stack: CO, H_2 , O_2 , H_2S , NH_3 ; Safety [H_2].

•Physical Sensors

–Temperature, pressure, relative humidity, flow, ΔP

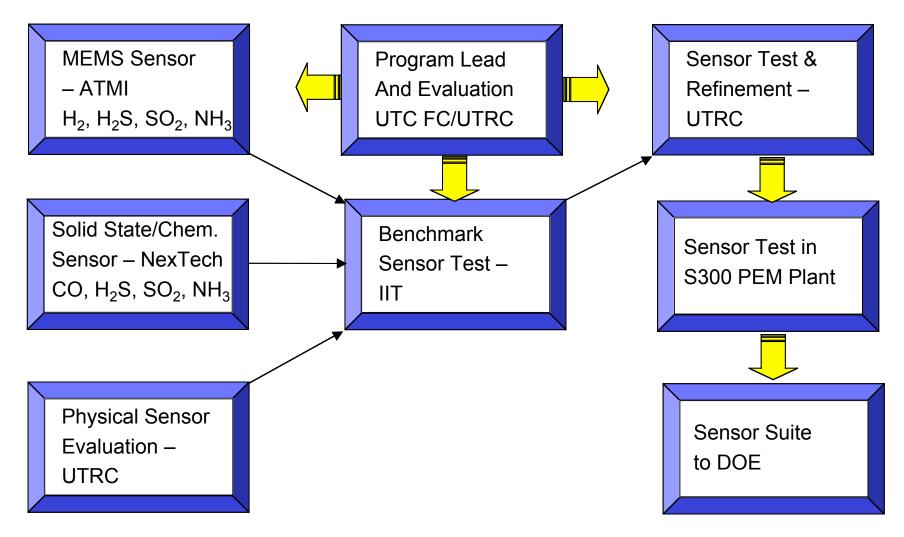
Sensor Program Team Responsibilities

- Sensor development program utilizes a team approach
 - UTRC for physical and chemical sensor evaluation and program coordination
 - Illinois Institute of Technology (IIT) for chemical sensor evaluation
 - Advanced Technical Materials (ATMI) for MEMS sensor development
 - NexTech Materials for electrochemical and solid state sensor development

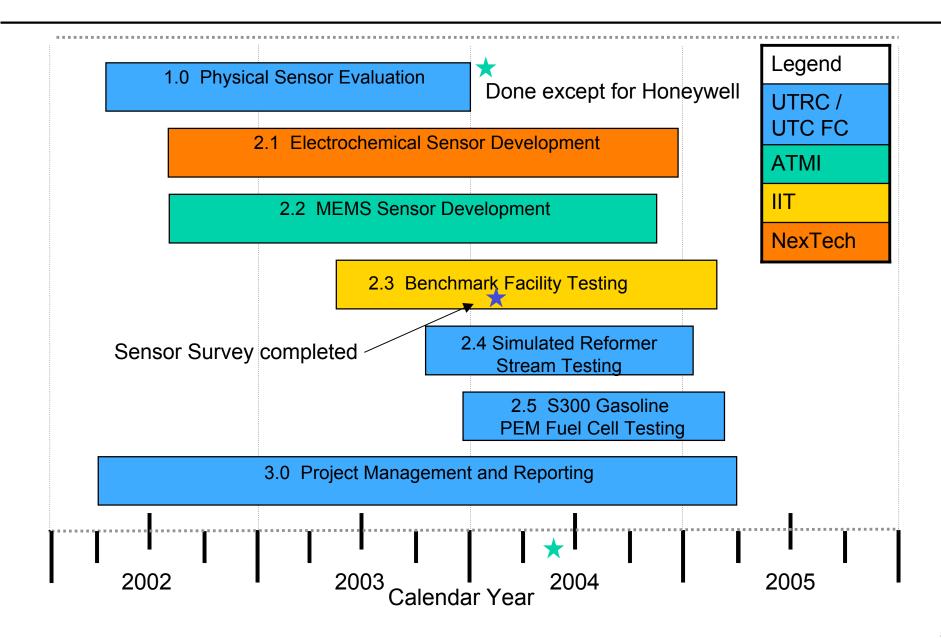
Team	Т	ΔΡ	RH	flow	O ₂	CO	H ₂	SO ₂	H ₂ S	NH ₃	Technological Expertise /
Member											Responsibility
UTC FC	Χ	Χ	Χ	Χ	Χ	Χ	Χ	Χ	Χ	Χ	Testing on S300
											Breadboard
UTRC	Χ	Χ	Χ	Χ	Χ	Χ	Χ	X	X	X	Testing in reformate
											simulator
ATMI							Χ	X	X	X	Develop Using MEMS
											Silicon Microhotplate
IIT	Х		Х		Х	Х	Х	Х	Х	X	Testing in Benchmark
											Facility
NexTech						Х		X	X	X	Develop Using Solid State
											Electrochemical

Sensor Program Team Structure

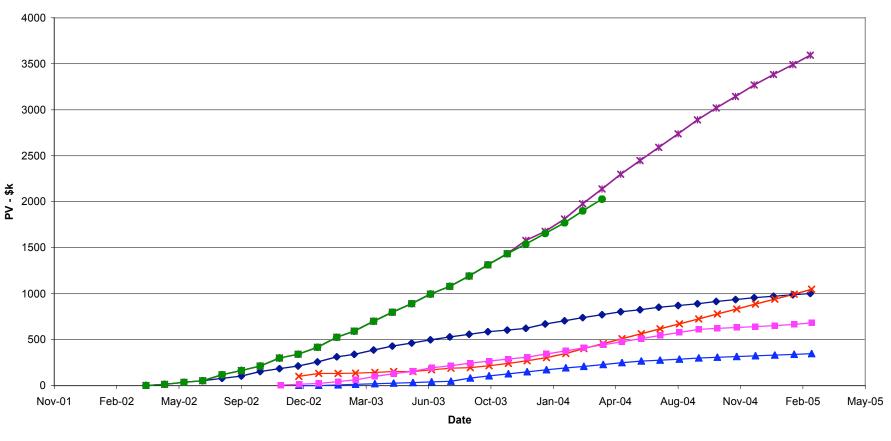
- Continuous interaction among team members
- ATMI, NexTech develop sensors, IIT and UTRC test and aid in optimization



Sensors for Automotive Fuel Cells Plan



Sensors Program Financial Status



•Total cost: \$3.7MM; DOE cost: \$3.0MM (80%) UTC Cost Share: \$0.7MM (20%)
•Total expended to date: \$1.6MM

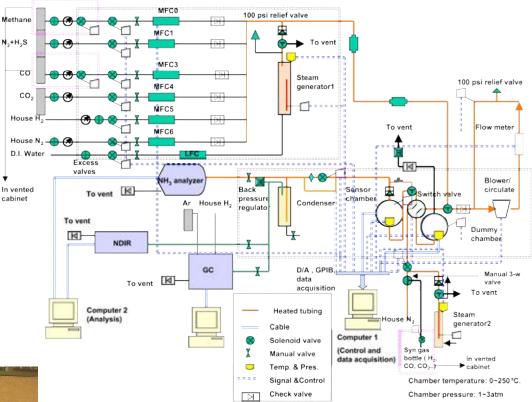
•Duration: April 2002 – March 2005

H₂ Safety Issues Associated with Project

- Use of H₂ in laboratory environment
 - Flammable gas detectors located in laboratory; relay opens and turns off power to solenoid valves on H_2 supply at 10% of LEL
 - LabView-based control program senses alarm, shuts off all other gases and purges all gas lines with N_2
 - All valves used in experiment are explosion-proof
 - Pressure relief valves used in all piping to prevent over-pressurization of components
- Sensor technology
 - Heated sensing elements can provide an ignition source; therefore the detection element must be separated from the gas stream by a flasharrestor (porous plate) to prevent ignition of the bulk gas

PEM Fuel Cell Gas Stream Simulators at UTRC & IIT

Both test rigs operate under LabView control for 24/7 operation (data acquisition and test matrix completion)



Test chamber (25 - 450°C) Pressure: 1-4 atm



UTRC test rig with dual chambers

IIT test rig

Sensor Evaluation Status at UTRC

Lei Chen and Brian Knight

- Physical Sensors
 - Sensors for T, P, ΔP, Relative Humidity (RH), and Flow evaluated in PEM fuel cell simulator in near-condensing flow regime
- State-of-the-art physical sensors meeting program needs selected
- Chemical Sensors
 - First round of sensor testing and qualification completed
 - Multiple H₂ sensors evaluated for sensitivity, selectivity, and performance
 - Possible extension of the testing effort beyond April 2005 being considered in order to accommodate field testing requested by Honeywell

Physical Parameter Sensors Results

•UTRC researched and tested multiple physical

sensors; most promising tabulated below

Sensor	Operating Principle	Positive Attributes	Development Needs
Temperature	Thermistor	0 to 250 °C, -40 to 750 °C	Response time needs improvement
Pressure	Strain gauge (Druck)	Silicon based IC compatible fabrication.	May be mass produced and miniaturized
RH	Polymer capacitive (Panametrics)	0 to 180 °C, 0- 100% RH	Improve recovery from condensing flow regime
Flow	Thermal dissipation	Most cost effective	Response fluctuation due to condensation



Joseph R. Stetter, William R. Penrose, William Buttner, and Kapil Gupta

- IIT evaluated over 70 H₂ sensing technologies
- Tiered approach used to evaluate sensor technologies
 - Gas concentration, operating temperature, water vapor pressure
 - Effect of pressure, other background gases
 - Long-term testing
- Hydrogen Sensors (Reformer)
 - -H2 Scan, Makel Engineering, ATMI, KSC NASA
- Hydrogen Sensors (Safety Application)

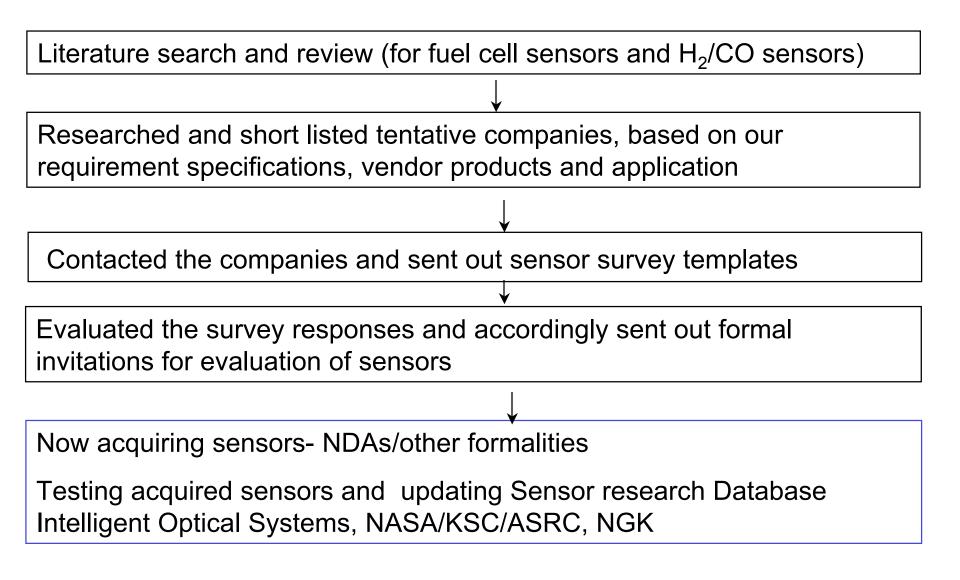
-H2 Scan, Applied Sensors, Makel Engineering, ATMI, Figaro, Transducer Technology, Inc., Argus Group, Nemoto Environmental Technology, Applied Nanotech

Carbon Monoxide Sensor

-NexTech Materials

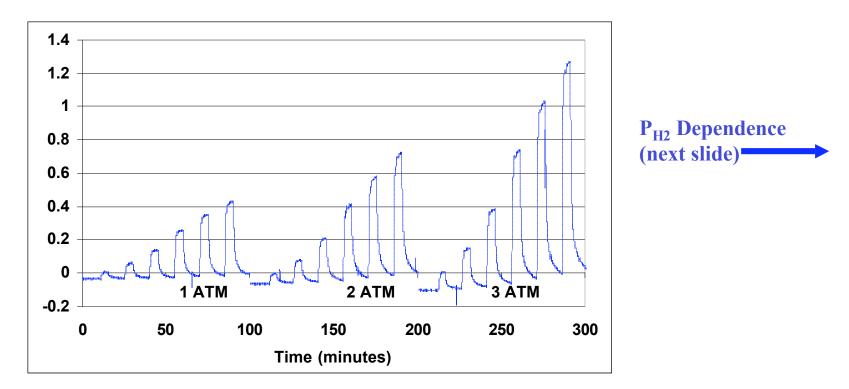
(Sensors currently available are listed in blue)







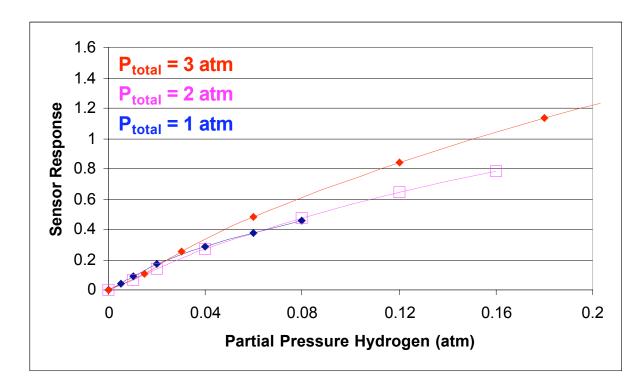
SSTUF: Hydrogen Sensor Response (0.5 to 8%) in air



Single Data Run

- Sensitivity Curves obtained for different pressures at 22°C
- Automated Pressure Control, Flow Control and Concentration
- Capabilities also include Temperature Control and Humidity Control

Hydrogen Sensor Response (0 to 0.2 atm) in air



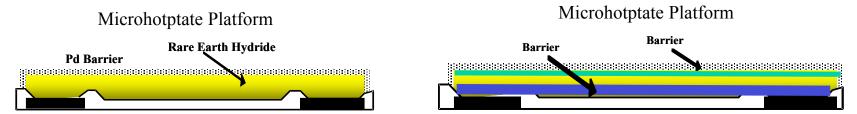
Sensor Sensitivity is often controlled by Partial Pressure of H_2 (not % H_2)

MEMS Sensor Development Task 1a Safety Sensor in Ambient Air



Ing-Shin Chen, Phil Chen, F. DiMeo, Jeff Neuner, Andreas Roehrl, Jim Welch

- Targets
 - [H₂]: 0-10%; Temp: -30 to 80°C, Response time: < 1 s; Humidity: 10-98%; Selectivity from hydrocarbons; Accuracy: 5%; Lifetime:5 yrs
- Approach
 - Fundamental materials engineering and process control
 - Optimization of operating conditions

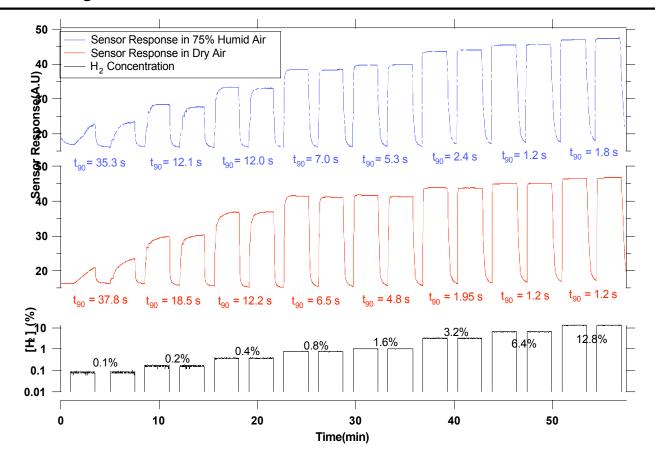


Accomplishments

- Developed and tested alpha, beta systems
- Demonstrated performance against performance targets
- Delivered alpha prototypes for IIT, UTRC for evaluation

MEMS Sensor Development Task 1a: Safety Sensor in Ambient Air

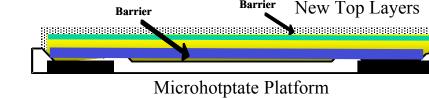




- Performance Demonstrated to date
 - [H₂]: 0-12.8%; Operating Temp: ~80°C,
 - Response time: < 2 s @ 4%, 1.2s @ 6%</p>
 - Environment: 0–75% RH;

MEMS Sensor Development Task 1b Pre Stack Monitor

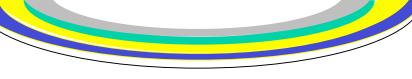
- Targets
 - [H₂]: 1-100%; Temp: 70- 150°C; Response (T₉₀):0.1-1 s; Environment: 1-3 atm total pressure, 10-30 mole % water, total H₂, 30-75%, CO₂, N₂ Accuracy: 1-10 % full scale
- Approach
 - Materials modifications of safety sensor design
 - Exploration of different transduction modes.



Barrier

Accomplishments

- Fabricated new materials combinations
- Investigated new transduction methods
- Delivered alpha prototypes to UTRC

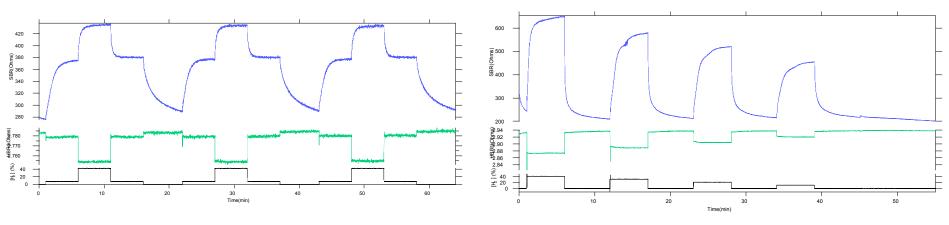


Piezo Resistive Transduction



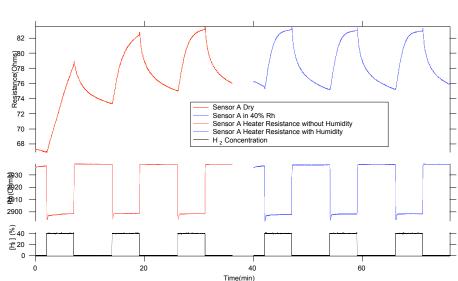
MEMS Sensor Development Task 1b Pre Stack Monitor





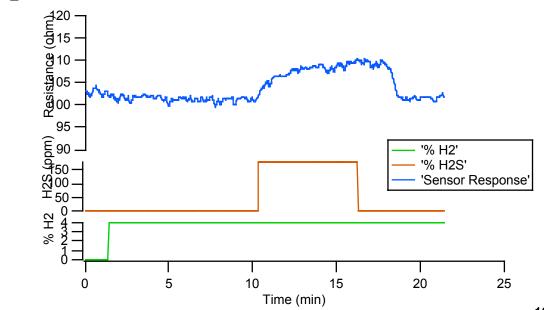
- Performance in Dry N_2
 - 0-4-40% H₂
 - 37 sec t90 0 4%
 - 2 sec t90 4 40%
 - -40 to 10% H₂
 - 31.8 sec 0-40%
- Performance in 70% RH
 - Similar to dry N₂

BQ-6-6B



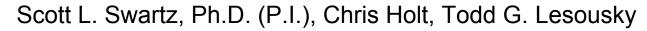
MEMS Sensor Development Task 2 H₂S Sensor Development

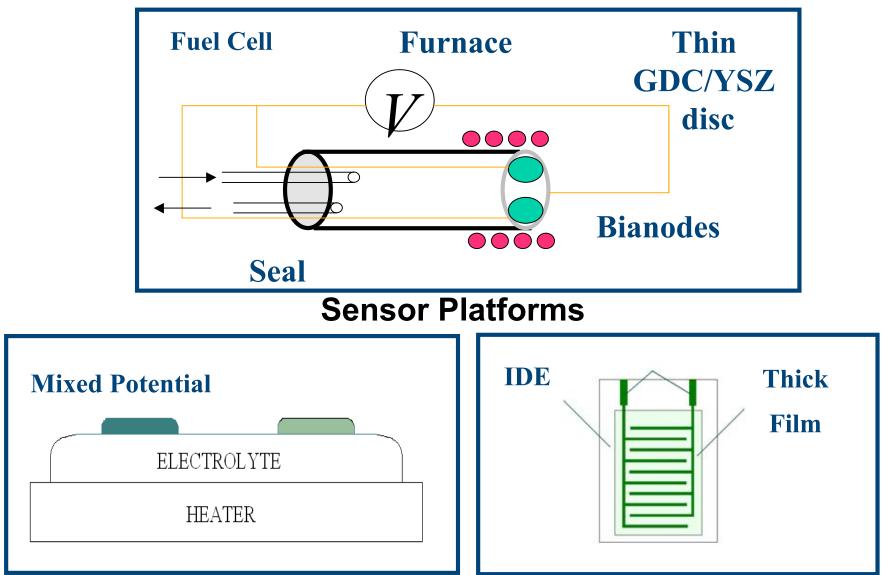
- Targets
 - Temp: 400°C; Range: 0.05 ppm -0.5 ppm; Response time: < 1 min at 0.05 ppm; Environment: H₂,CO, CO₂ H₂O
- Approach
 - Ultra thin (< 50nm) metal film deposition on micro hotplate platform
- Accomplishments
 - Demonstrated first sensor response to H_2S
 - 50 nm film responds to H₂S
 - 160°C, 4% H₂/N₂,
 - 20% RH,
 - 180 ppm H₂S



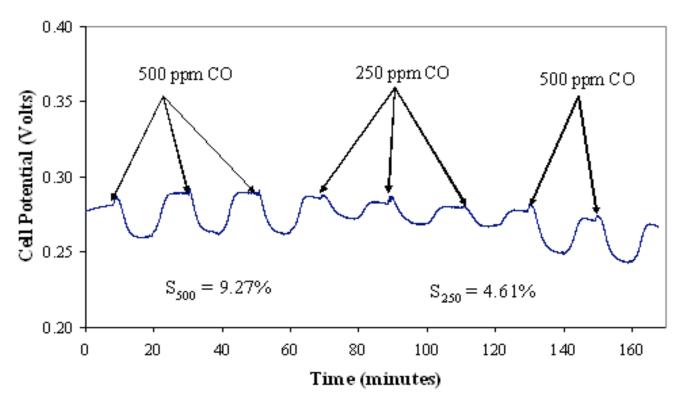
NexTech Materials Sensor Development

NEXTECH MATERIALS





NexTech Sensor Development Task 2.1.1 Miniature SOFC Fuel Cell Sensor



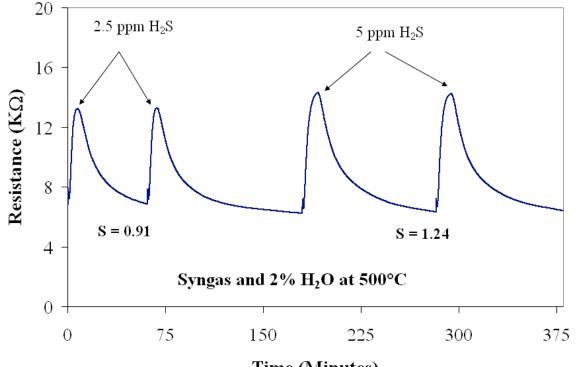
- NexTech's SOFC sensor technology with electrodes engineered to respond to CO show reversible and quantitative response to CO in wet N₂/H₂.
- Future work will focus on schemes to improve sensitivity for 0-100ppm CO range and testing cross-sensitivity to alternate syngas components

NEXTECH

MATERIALS

NexTech Sensor Development Task 2.1.2 Hydrogen Sulfide Sensors

 Metal oxide based chemi-resistor (not electrochemical sensor) exhibits reversible and quantitative response to H₂S



Time (Minutes)

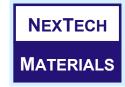
- NexTech is currently evaluating various dopant schemes to reduce the temperature of operation
- Beta prototypes scheduled for early June

NEXTECH

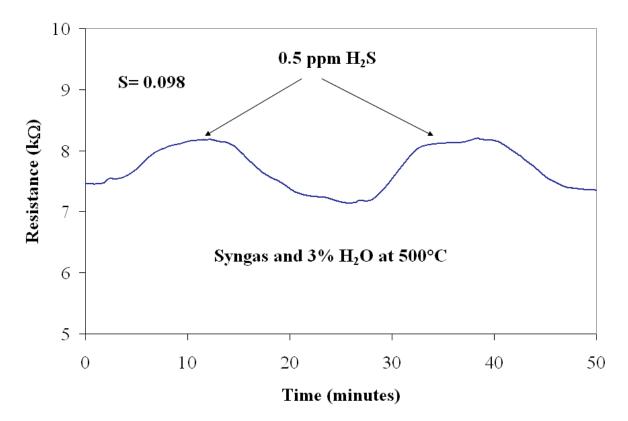
MATERIALS

NexTech Sensor Development

Task 2.1.2 Hydrogen Sulfide Sensors

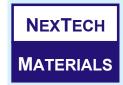


Metal Oxide films show reversible response to H₂S concentrations at 0.5 ppm in syngas (goal of 0.05 – 0.5 ppm).



•Future work will focus on measuring lower sulfur concentrations and crosssensitivity to individual syngas components.

NexTech Sensor Development Task 2.1.3 Ammonia Sensor Response



300 N₂/10 ppm NH₃ T=25°C S=8 250 NexTech's metal halide ammonia sensor Resistance (KΩ) 200 shows very high sensitivity at low 150 temperature 100 50 N₂ N_2 N_2 0 100 200 300 500 400 600 90 Time (Minutes) 5ppm NH₃ 85 Resistance (KQ) 80 Sensor responds reversibly in N_2/H_2 75°C at 75 Future work will focus on improving high 70 N_2/H_2 temperature sensitivity and measuring N_2/H_2 N_2/H_2 65 cross-sensitivity to other syngas 60 components. 20 100 0 40 60 80 Time (Minutes)

Responses to Previous Year Reviewers' Comments

- "..difficult to assess technical approach and progress"
 - Physical sensor evaluation completed
 - H₂ LEL sensor developed
 - Best response times <1 s, average ~14s; sensor drift rate < 0.16% / day
 - Stack H₂ sensor developed
 - Dynamic response up to 40% H_{2} , H_{2} levels up to 70%, with humidity
 - Fast response (T_{90} <2 sec) with Pd
 - New devices shows promise; minor cross sensitivity with CO; Drift <0.2% in 4% H₂
 - Multiple strategies identified for sensing CO in reducing environments; CO sensitivity established in humid environments
 - Multiple strategies for sulfur
 - ATMI- 50 nm Metal Foil shows response to H_2S
 - -NexTech
 - H₂S/SO₂ sensor materials identified
 - PPM level detection demonstrated

Ammonia sensor easily packaged in a chemi-resistor format

Sensors for Automotive PEM-based Fuel Cells Project

Team organization



DOE program manager and technical advisor:



Research Center

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